

March 7, 2008

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Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450 Art Unit 2851

Attn: Mail Stop RCE

Re: U.S. Utility Patent Application

Application No. 10/677,242; Filed: October 3, 2003

Method and Systems for Total Focus Deviation Adjustments on Maskless Lithography Systems

Inventor: Peter Kochersperger

Our Ref: 1857.2060000

Sir:

Transmitted herewith for appropriate action are the following documents:

1. Online Credit Card Payment Authorization in the amount of \$810.00 to cover:

\$ 810.00 fee for Request for Continued Examination (RCE);

- 2. Request for Continued Examination (RCE) Transmittal PTO/SB/30;
- 3. Fourth Supplemental Information Disclosure Statement;
- Form PTO/SB/08A (1 sheet) listing two (2) documents (US1 and FP1);
- 5. Form PTO/SB/08B (1 sheet) listing two (2) documents (NPL1-NPL2); and
- 6. Copies of cited documents (FP1 and NPL1-NPL2).

The above-listed documents are filed electronically through EFS-Web.

In the event that extensions of time are necessary to prevent abandonment of this patent application, then such extensions of time are hereby petitioned.

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Fee payment is provided through online credit card payment. The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

Michelle K. Holoubek Attorney for Applicant Registration No. 54,179

MKH/ahw Enclosures

DOC#791380_1.DOC